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Notice of Allowability	Application No.	Applicant(s)	
	10/612,977	LEE, JAE GU	
	Examiner	Art Unit	
	(Nancy) Thanh-Nhan P Nguyen	2871	
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.			
1. This communication is responsive to			
2. The allowed claim(s) is/are <u>1-8</u> .			
3. The drawings filed on <u>07 July 2003</u> are accepted by the Examiner.			
 4. Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some* c) None of the: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No 3. Copies of the certified copies of the priority documents have been received in this national stage application from the International Bureau (PCT Rule 17.2(a)). * Certified copies not received: Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application. THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 5. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient. 6. CORRECTED DRAWINGS (as "replacement sheets") must be submitted. (a) including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached 1) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No./Mail Date Identifying Indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the header according to 37 CFR 1.121(d). 7. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL. 			
Attachment(s) 1. ☑ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/O Paper No./Mail Date 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material	5. ☐ Notice of Informal P 6. ☐ Interview Summary Paper No./Mail Dat 7. ☐ Examiner's Amenda 8. ☑ Examiner's Stateme 9. ☐ Other	(PTO-413), te nent/Comment	·

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DETAILED ACTION

1. Claims 1-8 are presented for examination.

2. Claims 1-8 are allowed.

3. The prior art made of record and not relied upon is considered pertinent to

applicant's disclosure.

a. Ono et al U.S. Patent No. 6,762,802 discloses the fabricating method of a

liquid crystal display comprising: using photoresist pattern having at least two areas

which has different thickness from each other.

b. Kim et al U.S. Patent No. 6,744,486 discloses the fabricating method of a

liquid crystal display comprising: forming a photoresist on the passivation layer,

exposing the photoresist using a mask having a light shielding portion, a light

transmissive portion, and a semi-transmissive portion.

4. The following is an examiner's statement of reasons for allowance: Applicant's

claimed invention distinguishes over the prior art for the following reasons. The claims

are allowable over the prior art of record because none of the references, either alone

or in combination, discloses or renders obvious the fabricating method of a liquid crystal

display comprising: simultaneously forming a perforation hole and a contact hole by

selectively eliminating the protective film <u>using a partial exposure mask</u>.

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than the payment of the issue fee and, to avoid processing delays, should preferably

Any comments considered necessary by applicant must be submitted no later

accompany the issue fee. Such submissions should be clearly labeled "Comments on

Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the

examiner should be directed to (Nancy) Thanh-Nhan P Nguyen whose telephone

number is 571-272-1673. The examiner can normally be reached on M-F/9-5:30.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's

supervisor, Robert Kim can be reached on 571-272-2293. The fax phone number for

the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the

Patent Application Information Retrieval (PAIR) system. Status information for

published applications may be obtained from either Private PAIR or Public PAIR.

Status information for unpublished applications is available through Private PAIR only.

For more information about the PAIR system, see http://pair-direct.uspto.gov. Should

you have questions on access to the Private PAIR system, contact the Electronic

Business Center (EBC) at 866-217-9197 (toll-free).

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(Nancy) Thanh-Nhan P Nguyen

Examiner

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KENNETH PARKER

PRIMARY EXAMINER